AUTHOR INDEX

Arm	garth,	M.,	91
	B ,	,	

Belko, J. A., 161 Bergveld, P., 11, 109, 129 Bourke, P., 251

Danielsson, B., 91 Duszak, M., 245

Evans, A. G. R., 219

Firth, J. G., 281 Fjeldly, T. A., 261 French, P. J., 219

Gangal, S. A., 149 Gustafsson, K., 235

Hager, H. E., 161 Haskard, M. R., 3 Heiland, G., 101, 227 Hök, B., 235 Hoogerwerf, A. C., 39 Huang, P. H., 23 Jadhav, M. L., 149 Jakubowski, A., 245 Janoska, I., 3 Jones, T. A., 281

Karekar, R. N., 149 Kataoka, S., 29 King, A. A., 49 Kohl, D., 101, 227 Kordić, S., 197 Kostov, P. T., 307

Leppävuori, S., 271 Lundström, I., 91

McAleer, J. F., 251 Mann, B., 281 Martin, S. J., 319 Meijer, H. C., 187 Middelhoek, S., 39 Mlinar, J. W., 181 Mokwa, W., 101 Moseley, P. T., 251

Nagy, K., 261 Norris, J. O. W., 251

Otagawa, T., 65

Reinhoudt, D. N., 129 Ricco, A. J., 319 Romppainen, P., 271 Roumenin, Ch. S., 307

Sarro, P. M., 187 Spetz, A., 91 Stephan, R., 251 Stetter, J. R., 65 Sudhölter, E. J. R., 129 Sugiyama, Y., 29

Torvela, H., 271

Väänänen, J., 271 van der Berg, A., 129 van der Jagt, P. C. M., 197 van der Schoot, B., 11 van Herwaarden, A. W., 187

White, R. M., 49 Winquist, F., 91

Zaromb, S., 65 Zipperian, T. E., 319

SUBJECT INDEX

Acoustic wave

surface, gas sensor based on film conductivity changes, 319

Aluminum

humidity-sensitive $Al-nC-SiO_x-pSi-Al$ structures, 245

study of effect of humidity on AlO-x thin-film resistors, 149

Ammonia

biosensors based on ammonia sensitive metal-oxide-semiconductor structures, 91

Antimony

S/N study of micro-Hall sensors made of single crystal InSb and GaAs, 29

Arsenic

S/N study of micro-Hall sensors made of single crystal InSb and GaAs, 29

Arsine

an SnO₂ thin film for sensing, 101

Biosensors

based on ammonia sensitive metaloxide-semiconductor structures, 91

Carbon

humidity-sensitive Al-C-SiO_x-pSi-Al structures, 245

Carbon monoxide

detection by photoimpedance response of semiconductor film sensors, 161 effect of CH₄, SO₂ and NO on CO

response of SnO₂-based thick film gas sensor in combustion gases, 271

Cells

modular reaction, paper strips containing, 181

Chemical sensor

-actuator system, integration of; ISFET-based microlitre titrator, 11

Chemical surface

modification, sensitivity control of ISFETs by, 129

Combustion gases

effect of CH₄, SO₂ and NO on CO response of SnO₂-based thick film gas sensor in, 271

Conductivity changes

surface acoustic wave gas sensor based on film, 319

Differential potentiometric sensors glass electrodes with solid-state membrane contacts and their application in, 261

Electrical characterization

of water vapour/polymeric film system for humidity sensing, 23

Electrical conductivity

of some metal oxides in inert and reducing atmospheres at high temperature, effect of oxygen on, 281

Electrochemical sensor

and instrument for monitoring methane, room-temperature, 65

Electrodes

glass, with solid-state membrane contacts and their application in differential potentiometric sensors,

Electronic implantation

of sensitivity-variation offset-reduction method, theory and practice of, 197

Gallium

S/N study of micro-Hall sensors made of single crystal InSb and GaAs, 29

Glass electrodes

with solid-state membrane contacts and their application in differential potentiometric sensors, 261

Gas sensor(s)

oxidic and organic semiconductor, problems and possibilities, 227

surface acoustic wave, based on film conductivity changes, 319

tin dioxide

SnO₂-based thick film, effect of CH₄, SO₂ and NO on CO response of, in combustion gases, 271

use of Seebeck effect, 251

Hall sensors

S/N study of micro-, made of single crystal InSb and GaAs, 29

Humidity

study of effect of, on AlO-x thin-film resistors, 149

Humidity sensing

water vapour/polymeric film system for, electrical and thermodynamic characterization of, 23

Humidity-sensitive

Al-C-SiO_x-pSi-Al structures, 245

Indium

S/N study of micro-Hall sensors made of single crystal InSb and GaAs, 29

ISFET(s)

-based microlitre titrator; integration of chemical sensor-actuator system, 11

sensitivity control of, by chemical surface modification, 129

Magnetic field

functional multisensor for, and temperature measurements, 307

Metal oxides

effect of oxygen on electrical conductivity of some, in inert and reducing atmospheres at high temperatures,

Methane

effect of CH₄ on CO response of SnO₂-based thick film gas sensor in combustion gases, 271

room-temperature electrochemical sensor and instrument for monitoring, 65

Micromechanical elements

vibration analysis of, 235

Modular reaction cells paper strips containing, 181

MOSFET
-based sensors, impact of, 109

Multisensor

for magnetic field and temperature measurements, functional, 307

Nitrous oxide

effect of NO on CO response of SnO₂-based thick film gas sensor in combustion gases, 271 Offset-reduction method

sensitivity-variation, theory and practice of electronic implementation of, 197

Optical image

tactile sensing array based on forming and detecting, 49

Oxygen

effect of, on electrical conductivity of some metal oxides in inert and reducing atmospheres at high temperature, 281

Photoimpedance response

CO detection by, of semiconductor film sensors, 161

Polymeric film system

water vapour/, for humidity sensing, electrical and thermodynamic characterization of, 23

Reaction cells

paper strips containing modular, 181

Resistors

AlO-x thin-film, study of effect of humidity on, 149

Seebeck effect

tin dioxide gas sensors, use of Seebeck effect, 251

Semiconductor

biosensors based on ammonia sensitive metal-oxide-semiconductor structures, 91

film sensors, CO detection by photoimpedance of, 161

gas sensors, problems and possibilities of oxidic and organic, 227

Sensitivity control

of ISFETs by chemical surface modification, 129

Sensitivity-variation

offset-reduction method, theory and practice of electronic implementation of, 197

Sensor(s)

differential potentiometric, glass electrodes with solid-state membrane contacts and their application in, 261

electrochemical, and instrument for monitoring methane, room-temperature, 65 functional multisensor for magnetic field and temperature measurements, 307

gas

oxidic and organic semiconductor, problems and possibilities of, 227 SnO2-based thick film, effect of CH₄, SO₂ and NO on CO response of, in combustion gases, 271 surface acoustic wave, based on film conductivity changes, 319 tin dioxide; use of Seebeck effect, 251 integrated vacuum, 187 micro-Hall, made of single crystals InSb and GaAs, S/N study of, 29 MOSFET-based, impact of, 109 polycrystalline silicon strain, 219 semiconductor film, CO detection by photoimpedance response of, 161 smart; when and where? 39

Sensor-actuator system

chemical, integration of; ISFETbased microlitre titrator, 11

Silicon

humidity-sensitive Al-C-SiO_x-pSi-Al structures, 245 polycrystalline silicon strain sensors, 219

Smart sensors

when and where? 39

Strain sensors

polycrystalline silicon, 219

Sulphur dioxide

effect of SO₂ on CO response of SnO₂-based thick film gas sensor in combustion gases, 271 Tactile sensing array

based on forming and detecting an optical image, 49

Temperature measurements

functional multisensor for magnetic field and, 307

Temperature sensor

thick film standard paste, applications, 3

Thermodynamic characterization of water vapour/polymeric film system for humidity sensing, 23

Tin dioxide

effect of CH₄, SO₂ and NO on CO response of SnO₂-based thick-film gas sensor in combustion gases, 271 gas sensors; use of Seebeck effect, 251 an SnO₂ thin film for sensing arsine, 101

Titrator

ISFET-based microlitre; integration of chemical sensor-actuator system, 11

Vacuum sensor integrated, 187 Vibration analysis of micromechanical elements, 235

Water vapour

/polymeric film system for humidity sensing, electrical and thermodynamic characterization of, 23